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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/821,357	04/09/2004	Gregory D. Miller	10021.000201 (P0177-D)	1202
31894 7	590 07/25/2006		EXAM	INER
	OKAMOTO & BENEDICTO, LLP P.O. BOX 641330		ROSENAU, DEREK JOHN	
SAN JOSE, CA 95164			ART UNIT	PAPER NUMBER
·			2834	
			DATE MAILED: 07/25/2006	5

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)
Office Action Summary		10/821,357	MILLER ET AL.
		Examiner	Art Unit
		Derek J. Rosenau	2834
Period f	The MAILING DATE of this communication a for Reply	ppears on the cover sheet wit	h the correspondence address
A SH WHI - Ext afte - If N - Fail Any	HORTENED STATUTORY PERIOD FOR REF CHEVER IS LONGER, FROM THE MAILING ensions of time may be available under the provisions of 37 CFR er SIX (6) MONTHS from the mailing date of this communication. O period for reply is specified above, the maximum statutory period ture to reply within the set or extended period for reply will, by state y reply received by the Office later than three months after the manned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNIC 1.136(a). In no event, however, may a re od will apply and will expire SIX (6) MONI oute, cause the application to become ABA	ATION. ply be timely filed THS from the mailing date of this communication. ANDONED (35 U.S.C. § 133).
Status			
1)⊠	Responsive to communication(s) filed on 25	May 2006.	
2a)⊠	This action is FINAL . 2b) ☐ The	nis action is non-final.	
3)[Since this application is in condition for allow	•	
	closed in accordance with the practice unde	r <i>Ex parte Quayle</i> , 1935 C.D.	11, 453 O.G. 213.
Disposi	tion of Claims		
4)⊠	Claim(s) 17-33 is/are pending in the applicat	tion.	
	4a) Of the above claim(s) is/are withd	rawn from consideration.	
5)[Claim(s) is/are allowed.		
	Claim(s) <u>17-33</u> is/are rejected.		
•	Claim(s) is/are objected to.		
8)[Claim(s) are subject to restriction and	l/or election requirement.	
Applica	tion Papers		
9)[The specification is objected to by the Exami	ner.	
10)区	The drawing(s) filed on 25 May 2006 is/are:	a)⊠ accepted or b)☐ object	ted to by the Examiner.
	Applicant may not request that any objection to the	• , ,	
	Replacement drawing sheet(s) including the corre		
11)[_	The oath or declaration is objected to by the	Examiner. Note the attached	Office Action or form P1O-152.
Priority	under 35 U.S.C. § 119		
12)[Acknowledgment is made of a claim for foreign	gn priority under 35 U.S.C. §	119(a)-(d) or (f).
а)		
	1. Certified copies of the priority docume		
	2. Certified copies of the priority docume		
	3. Copies of the certified copies of the pr		received in this National Stage
	application from the International Bure	•	
_	See the attached detailed Office action for a li	st of the certified copies flot i	eceived.
Attachme	nt(s)		
	ice of References Cited (PTO-892)		ummary (PTO-413)
	ice of Draftsperson's Patent Drawing Review (PTO-948) ormation Disclosure Statement(s) (PTO-1449 or PTO/SB/0)/Mail Date formal Patent Application (PTO-152)

Paper No(s)/Mail Date _____.

3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)

6) Other: ____.

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DETAILED ACTION

Drawings

1. The drawings were received on 5/25/06. These drawings are accepted.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 17, 19-25, 31 and 32 are rejected under 35 U.S.C. 103(a) as being unpatentable over Pahl et al. (US 6931699) in view of Gupta et al. (US 5955659).
- 1. With respect to claim 17, Pahl et al. discloses a surface acoustic wave (SAW) device sealed at the wafer level (Figures 1-7), the device comprising: an active area to be protected (item 5); an electrical contact area (item 10); and a lithographically-formed (column 4, lines 11-16) structure sealing at least the active area and leaving at least a portion of the electrical contact area exposed (Figures 6 and 7).

Pahl et al. does not disclose expressly that the lithographically-formed structure comprises a seal coating deposited over a sacrificial material, said sacrificial material being subsequently removed by etching.

Gupta et al. teaches a lithographically-formed structure (Fig 11a-11e) in which a seal coating (item 231) is deposited over a sacrificial material (item 208), said sacrificial material being subsequently removed by etching (column 7, line 56 through column 89, line 10).

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At the time of invention, it would have been obvious to a person of ordinary skill in the art to combine the lithographically-formed seal coating of Gupta et al. with the SAW device of Pahl et al. for the benefit of forming the seal coating as a single piece.

- 4. With respect to claim 19, the combination of Pahl et al. and Gupta discloses the device of claim 17. Pahl et al. discloses that the SAW device is fabricated on a substrate from a group consisting of lithium tantalite, lithium niobate, and quartz (column 3, lines 48-50).
- 5. With respect to claim 20, Pahl et al. discloses a lithographically-fabricated surface acoustic wave (SAW) device (Figs 1-7), the SAW device comprising: means for carrying a surface acoustic wave (item 1); and a wafer-level means for sealing the means for carrying the surface acoustic wave (items 7-9).

Pahl et al. does not disclose expressly that said wafer-level means for sealing comprises a seal coating deposited over a sacrificial material, said sacrificial material being subsequently removed by etching.

Gupta et al. teaches a lithographically-formed structure (Fig 11a-11e) in which the wafer-level means for sealing comprises a seal coating (item 231) deposited over a sacrificial material (item 208), said sacrificial material being subsequently removed by etching (column 7, line 56 through column 89, line 10).

At the time of invention, it would have been obvious to a person of ordinary skill in the art to combine the lithographically-formed seal coating of Gupta et al. with the SAW device of Pahl et al. for the benefit of forming the seal coating as a single piece.

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6. With respect to claim 21, the combination of Pahl et al. and Gupta et al. discloses the SAW device of claim 20. Pahl et al. discloses that the means for carrying the surface acoustic wave comprises a transducer structure (items 2a and 2b).

- 7. With respect to claim 22, the combination of Pahl et al. and Gupta et al. discloses the SAW device of claim 21. Pahl et al. discloses that the transducer structure comprises aluminum (column 3, lines 55 and 56) patterned into interdigitated electrode fingers (items 2a and 2b).
- 8. With respect to claim 23, the combination of Pahl et al. and Gupta et al. discloses the SAW device of claim 20. Pahl et al. discloses that the wafer-level means for sealing comprises a lithographically-formed structure sealing at least the means for carrying (Figures 6 and 7).
- 9. With respect to claim 24, the combination of Pahl et al. and Gupta et al. discloses the SAW device of claim 23. Pahl et al. discloses electrical contact areas coupled to the means for carrying, and wherein the wafer-level means for sealing leaves exposed at least a portion of the electrical contact areas (item 10).
- 10. With respect to claim 25, the combination of Pahl et al. and Gupta et al. discloses the device of claim 17. Pahl et al. discloses that the lithographically-formed structure comprises a material of a thickness so as to be impermeable to undesired contaminants (column 4, lines 42-47).
- 11. With respect to claim 31, the combination of Pahl et al. and Gupta et al. discloses the device of claim 17. Pahl et al. discloses that the SAW device is fabricated on a lithium tantalite substrate (column 3, lines 48-50).

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12. With respect to claim 32, the combination of Pahl et al. and Gupta et al. discloses the device of claim 17. Pahl et al. discloses that the SAW device is fabricated on a lithium niobate substrate (column 4, lines 48-50).

- 13. Claims 18, 26-28, and 33 are rejected under 35 U.S.C. 103(a) as being unpatentable over Pahl et al. in view of Gupta et al. in further view of Onishi et al. (US 6154940).
- 14. With respect to claim 18, the combination of Pahl et al. and Gupta et al. discloses the device of claim 17.

Neither Pahl et al. nor Gupta et al. disclose expressly that the lithographicallyformed structure comprises a glassy material.

Onishi et al. teaches a SAW device that uses a glassy material to seal the active area (column 7, lines 43-51).

At the time of invention, it would have been obvious to a person of ordinary skill in the art to combine the glassy-material of Onishi et al. with the SAW device of Pahl et al. in order make the device more compatible with common electronics manufacturing processes.

15. With respect to claim 26, the combination of Pahl et al. and Gupta et al. discloses the device of claim 17.

Neither Pahl et al. nor Gupta et al. disclose expressly that the lithographicallyformed structure comprises silicon dioxide.

Onishi et al. teaches a SAW device that uses silicon dioxide to seal the active area (column 7, lines 43-51).

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At the time of invention, it would have been obvious to a person of ordinary skill in the art to combine the silicon dioxide of Onishi et al. with the SAW device of Pahl et al. in order make the device more compatible with common electronics manufacturing processes.

16. With respect to claim 27, the combination of Pahl et al. and Gupta et al. discloses the device of claim 17.

Neither Pahl et al. nor Gupta et al. disclose expressly that the lithographicallyformed structure comprises silicon nitride.

Onishi et al. teaches a SAW device that uses silicon nitride to seal the active area (column 7, lines 43-51).

At the time of invention it would have been obvious to a person of ordinary skill in the art to combine the silicon nitride of Onishi et al. with the SAW device of Pahl et al. in order make the device more compatible with common electronics manufacturing processes.

17. With respect to claim 28, the combination of Pahl et al. and Gupta et al. discloses the device of claim 17.

Neither Pahl et al. nor Gupta et al. disclose expressly that the lithographicallyformed structure comprises a metal.

Onishi et al. teaches a SAW device that uses a metal to seal the active area (column 7, lines 43-51).

At the time of invention it would have been obvious to a person of ordinary skill in the art to combine the metal of Onishi et al. with the SAW device of Pahl et al. in order make the device more compatible with common electronics manufacturing processes.

18. With respect to claim 33, the combination of Pahl et al. and Gupta et al. discloses the device of claim 17.

Neither Pahl et al. nor Gupta et al. disclose expressly that the SAW device is fabricated on a quartz substrate.

Onishi et al. teaches a SAW device fabricated on a quartz substrate (column 15, lines 41-43).

At the time of invention it would have been obvious to a person of ordinary skill in the art to combine the quartz substrate of Onishi et al. with the SAW device of Pahl et al. in order make the device more compatible with common electronics manufacturing processes.

- 19. Claim 29 is rejected under 35 U.S.C. 103(a) as being unpatentable over Pahl et al. in view of Gupta et al. in further view of Bashir et al. (US 6716620).
- 20. With respect to claim 29, the combination of Pahl et al. and Gupta et al. discloses the device of claim 18.

Neither Pahl et al. nor Gupta et al. disclose expressly that the glassy material comprises a spin-on-glass.

Bashir et al teaches an electronic device in which the chip is sealed by spin-onglass (column 7, lines 51-57).

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At the time of invention, it would have been obvious to a person of ordinary skill in the art to combine the spin-on-glass of Bashir et al. with the SAW device of Pahl et al. in order to make the device more compatible with common manufacturing processes.

- 21. Claim 30 is rejected under 35 U.S.C. 103(a) as being unpatentable over Pahl et al. in view of Gupta et al. in further view of Orcutt et al. (US 6743656).
- 22. With respect to claim 30, the combination of Pahl et al. and Gupta et al. discloses the device of claim 18.

Neither Pahl et al. nor Gupta et al. disclose expressly that the glassy material comprises a sputtered glass.

Orcutt et al teaches an electronic device in which the chip is sealed by sputtered glass (column 4, line 67 through column 5, line 2).

At the time of invention, it would have been obvious to a person of ordinary skill in the art to combine the spin-on-glass of Orcutt et al. with the SAW device of Pahl et al. in order to make the device more compatible with common manufacturing processes.

Response to Arguments

23. Applicant's arguments with respect to claims 17-33 have been considered but are most in view of the new ground(s) of rejection.

Conclusion

24. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

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A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Derek J. Rosenau whose telephone number is 571-272-8932. The examiner can normally be reached on Monday thru Thursday 7:00-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Darren Schuberg can be reached on 571-272-2044. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Derek J Rosenau Examiner Art Unit 2834

DJR 7/20/06

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